IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IFW

In repatent application of

Lin HAI, et al.

Serial No.:

10/573,446

Filed:

March 24, 2006

Examiner:

Group Art Unit:2871

Unknown

For:

PLASMA DISPLAY PANEL AND METHOD OF

MANUFACTURING SAME

Honorable Commissioner of Patents Alexandria, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to Applicants' duty of disclosure under 37 CFR §1.56, Applicants respectfully bring the following documents cited in the International Search Report (previously filed on July 13, 2006) in a counterpart foreign application and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. Further, Japanese No. JP2002-033053 corresponds to US Patent No.6,788,373. Also, JP2003-031130 corresponds to US Patent No.6,674,238, and JP Hei 10-233157 corresponds to US Patent Nos.6,013,309 and 6,379,783.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which Applicants are aware.

In compliance with the concise explanation requirement under 37 CFR §1.98(a)(3) for foreign language documents, Applicants enclose herewith a copy of the International Search Report citing such documents, together with an English-language version (if not already included) of that portion of the Search Report indicating the degree of relevance found by the foreign office. Further, English language abstracts are attached to the references.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Date:

MCGINN INTELLECTUAL PROPERTY

LAW GROUP, PLLC

8321 Old Courthouse Road, Suite 200 Vienna, Virginia 22182-3817 (703) 761-4100

Customer No. 21254

Respectfully, submitted,

Sean M. McGinn, Esq. Registration No. 34,386

					Docket Number (Optional) 04-41 PUS		Application Number 10/573,446			
]	INFO	RMATION DISCLOSURI	E CITATION	4001	Applicant(s)		10/2	,,,,,,,		
		(Use several sheets if necess	ary)	ann	Lin HAI, et al.	——т	Sana Ant Valt			
	••	No. of the Control of	DEC 08	Jana R	Filing Date March 24, 200	Group Art Unit 2871				
27 277			THE U.S	. PATENT	DOCUMENTS					
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
		6,013,309	01/11/2000	Kim, et	al.					
		US 6,788,373 B2	09/07/2004	Ito, et a	1.					
		US 6,674,238 B2	01/06/2004	Otani, e	et al.					
		US 6,379,783 B1	04/30/2002	Kim, et	al.					
		, st								
			U.S. PATEN	T APPLICA	ATION PUBLICATIONS	an pr man promise				
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME		CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
		-								
		·								
			FORE	IGN PATE	NT DOCUMENTS					
	REF	DOCUMENT NUMBER DATE		COUNTRY CLAS			SUBCLASS	YES YES	slation NO	
		2003-31130	01/03/2003	Japan				ABS		
		2002-33053	01/31/2002	Japan				ABS		
		10/233157	09/02/1998	Japan				ABS		
		7-37510	02/07/1995	95 Japan				ABS		
		2000-156153	06/06/2000) Japan				ABS		
				DOCUMEN		or, Title, Date, l	Pertinent Pages, E	Etc.)		
		International Search R	Report dated Janua	ary 18, 200	05		-			
EXAMINE	ER				DATE CONSIDERED					
EXAMINE not conside	ER: Init	tial if citation considered, whethe	r or not citation is i	n conforma applicant.	nce with MPEP Section 609;	Draw line thro	ough citation if no	ot in conform	nance and	
Form PTC)-A820	•		P09	PA/REV05	Patent and Trader	nark Office * U.S. DE	PARTMENT OF	F COMMERCE	

(also form PTO-1449)

Application Number

		1/.	•	OF	_	04-41 PUS2	2001	10/	573,446	
	INFO	RMA	TION DISCLOSURI Use several sheets if necess	E CITATION	4087	Applicant(s) Lin HAI, et al.				1
		(Use several sheets if necess	ary)/	ر ده س	Filing Date	G	roup Art Unit		
	nec 08 3				<i>100</i> &)	March 24,	2006	28717		
				U.S DATE	. PASENT	DOCUMENTS				
	ĭ	T		TRADE	W			T	FILING	DATE
EXAMINER INITIAL	REF	ł	DOCUMENT NUMBER	DATE	ĺ	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	<u> </u>									
		ļ	· · · · · · · · · · · · · · · · · · ·						 	
·	Ì			İ					l	
							-			
						<u> </u>			<u>i — — </u>	
			•	U.S. PATENT	Γ APPLICA	TION PUBLICATIONS	··· •			
EXAMINER	REF		DOCUMENT NUMBER	DATE		NAME		SUBCLASS	FILING DATE	
INITIAL	KEI	 		DATE			CLASS		IF APPRO	PRIATE
		-			-			<u> </u>		
			•							
									1	
				FORE	IGN PATE	NT DOCUMENTS	· · · · · · · · · · · · · · · · · · ·			
	REF	1	DOCUMENT NUMBER	DATE	COUNTRY		CLASS	SS SUBCLASS	Tran: YES	slation NO
		7.20		11/10/1995	Ionon	Ionon			ABS	
	<u> </u>	9-167566 8-287823 7-192630		11/10/1993	Japan			 		
	1			06/24/1997	Japan				ABS	
<u></u>				11/01/1996 Japan					ABS	
	<u> </u>									
				07/28/1995	Japan		·		ABS	
	 			03/23/2001	Japan				ABS	
	2001-70029 03/23/20							!		
				OTHER I	DOCUMEN	TS (Including Au	thor, Title, Date, P	ertinent Pages, I	Etc.)	
							•			
			1					•		
								W 1 3000		
EXAMINER						DATE CONSIDERED				
						1				
EXAMINE not consider	ER: Ini ered	tial if c nclude	itation considered, whethe copy of this form with nex	r or not citation is it t communication to	n conforma applicant.	nce with MPEP Section 6	09; Draw line thro	ugh citation if n	ot in contorn	nance and
			PJ tille total men nev							
Form PTC	D-A820)	•		P09	A/REV05	Patent and Tradem	ark Office * U.S. Di	PARTMENT OF	F COMMERCE

Docket Number (Optional)

(also form PTO-1449)

Application Number